

AUG 14 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Wu et al.

Attorney Docket No.:
NOVLP094/NVLS-2919

Application No.: 10/789,103

Examiner: Bret P. Chen

Filed: February 27, 2004

Group: 1762

Title: METHODS FOR PRODUCING LOW-
K CDO FILMS WITH LOW RESIDUAL
STRESS**CERTIFICATE OF FACSIMILE TRANSMISSION**I hereby certify that this correspondence is being transmitted by
facsimile to fax number 571-273-8300 to the U.S. Patent and
Trademark Office on August 14, 2006.

Signed:

Tara Hayden

AMENDMENT B - AFTER FINALMail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated June 14, 2006 in the above-identified
application, please amend the application as follows:

Amendments to the claims are reflected in the Listing of Claims that begins on page 2 of this
paper.

Remarks/Arguments begin on page 7 of this paper.

Application No.: 10/789,103

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